

Electronic Acknowledgement Receipt

EFS ID:	2972977
Application Number:	10670855
International Application Number:	
Confirmation Number:	9751
Title of Invention:	APPARATUS FOR POLISHING A SEMICONDUCTOR WAFER AND METHOD THEREFOR
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Filer Authorized By:	Anthony Peter Onello
Attorney Docket Number:	SAM-0225DIV
Receipt Date:	10-MAR-2008
Filing Date:	25-SEP-2003
Time Stamp:	15:18:52
Application Type:	Utility under 35 USC 111(a)

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File Listing:					
Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Miscellaneous Incoming Letter	0225DIVtransmittal.pdf	67423 <small>08a815504b2d609aa62d9431c0cffe9c512dd240</small>	no	1
Warnings:					
Information:					
2	Request for Certificate of Correction	0225DIVpetforcertofcorr.pdf	379285 <small>f17a587e86bae8e61bb6ae7a480560e2f11be806</small>	no	4
Warnings:					
Information:					
3	Fee Worksheet (PTO-06)	fee-info.pdf	8187 <small>2555491d7ea0d522b48b4ef3c25509101a7f35d1</small>	no	2
Warnings:					
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